03500.015334.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	•	Examiner: Kabari Guharay
KAZUYA ISHIWATA ET AL.)	
	:	Group Art Unit: 2879
Application No.: 09/846,364)	
	:	
Filed: May 2, 2001)	
	:	
For: A SUBSTRATE STRUCTURE)	
WHICH IS A PRECURSOR TO AN	•	
ELECTRON SOURCE, AND)	
HAVING A SUBSTRATE AND AN	:	
INSULATING MATERIAL LAYER)	
WITH METAL OXIDE PARTICLES	:	
(As Amended))	March 1, 2004
Mail Stop RCE		
Commissioner for Patents		
P.O. Box 1450		
Alexandria, VA 22313-1450		

PRELIMINARY AMENDMENT

Sir:

A Request for Continued Examination is being filed herewith. Preliminary to continued examination, please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 1, 2004.

(Date of Deposit)

FRANK A. DeLUCIA (REG. NO. 42,476)

(Name of Attorney for Applicant)

Signature

March 1, 2004

Date of Signature